

Attorney Docket No.: 99CON114P

AMENDMENT COVER SHEET

IN RE APPLICATION OF: Liu et al.	
SERIAL NO.: 09/575,055 FILED: May 19, 2000	
FOR: Method for Selective Fabrication of High Capacitance Density Areas in a Low Dielectric Cons Related Structure	stant Material and
HONORABLE COMMISSIONER OF PATENTS AND TRADEMARKS	SENE SENE
Washington, D.C. 20231 Sir:	CENTER

Transmitted herewith is a paper in the above-identified application. Any necessary extension of time period settler this paper is hereby requested.

- ☐ No additional fee is required.
- ∑ The fee has been calculated as shown below:

EXTENSION FEE	RATE Non-Small Entity	RATE Small-Entity	PEE
FIRST MONTH AFTER TIME PERIOD SET	110.00	55.00	\$ 110.00
SECOND MONTH AFTER TIME PERIOD SET	400.00	200.00	\$
THIRD MONTH AFTER TIME PERIOD SET	920.00	460.00	\$
FOURTH MONTH AFTER TIME PERIOD SET	1,440.00	720.00	\$

- ☑ TOTAL EXTENSION FEE \$ 110.00
- ☐ FEE FOR EXTRA CLAIMS added by Amendment in this response:

	Column 1	Column 2	Column 3			
	Number of Claims after Amendment	Number Previously Paid for	Number of Extra Claims	RATE Non-Small Entity	RATE Small Entity	FEE
TOTAL CLAIMS	23	MINUS **27	* = 0	x 18	x 9	\$
INDEPENDENT	4	MINUS ***5	* = 0	x 84	<u>x 42</u>	\$
First presentation of multiple dependent claim				+ 280	+ 140	\$

TOTAL FEE FOR EXTRA CLAIMS \$ 0.00

- * If the entry in Column 1 is less than the entry of Column 2, write "0" in Column 3.
- ** If the number of Total Claims previously paid for is less than 20, write "20" in this space.
- *** If the number of Independent Claims previously paid for is less than 3, write "3" in this space.

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	Total fee for Supplemental Information Disclosure Statement \$			
×	Enclosed is the total fee of $$110.00$.			
	Please charge Deposit Account No. 50-0731 in the amount of \$			
, X	The Commissioner is hereby authorized to charge payment of any additional fees associated with this communication, or credit any overpayment to Deposit Account No. 50-0731. A duplicate copy of this sheet is enclosed.			
Date: _	10/1/02	By: Michael Farjami, Reg. No. 38,135		
Farjami 16148 S	I Farjami, Esq. & Farjami LLP Sand Canyon CA 92618 84-4600	I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on: Date Dirichted Typed or Printed Name of Person Mailing Paper and/or Fee		



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Liu, et al.

Serial No.: 09/575,055

Filed: May 19, 2000

For: Method For Selective Fabrication Of High Capacitance Density Areas In A Low Dielectric Constant Material

And Related Structure

Art Unit: 2825

Examiner: Chuong A. Luu

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Dear Sir/Madam:

This is in response to the Office Action dated June 4, 2002 in the above-referenced patent application. Please enter and consider the following amendments and remarks.

10/09/2002 DTESSEM1 00000039 09575055

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